

In re Application of:

YOSHINOBU SEKIGUCHI, et al.

Application No.: 10/566,170

371(c) Date: January 27, 2006

For: SEMICONDUCTOR FILM
MANUFACTURING METHOD AND
SUBSTRATE MANUFACTURING METHOD

Mail Stop Amendment
THE COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	* 15	MINUS	** 31	= 0	x \$25 \$50	\$ 0.00
INDEP. CLAIMS	* 7	MINUS	*** 3	= 4	x \$105 \$210	\$840.00
Fee for Multiple Dependent claims \$185°/\$370						\$ 0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$840.00

* If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.

*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

- Verified Statement claiming small entity status is enclosed, if not filed previously.
- A check in the amount of \$840.00 is enclosed.
- Charge \$_____ to Deposit Account No. 06-1205.
- Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
- A check in the amount of \$_____ to cover the fee for a _____ month extension is enclosed.
- A check in the amount of \$180.00 to cover the Information Disclosure Statement fee is enclosed.
- Applicants' undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Daniel E. Vadnais
Attorney for Applicants
Registration No.: 52,310

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200

Form #120

FCHS_WS 1893284v1

00862.109138.

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

YOSHINOBU SEKIGUCHI, et al.

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Examiner: Calvin Lee
Group Art Unit: 2818
January 15, 2008

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated October 15, 2007, please amend the above-identified application, as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

January 15, 2008
(Date of Deposit)

Damond E. Vadnais, Reg. No. 52,310
(Name of Attorney for Applicants)


Signature _____

January 15, 2008
Date of Signature

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